

Emage

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD,
SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR DEVICE
MANUFACTURING METHOD



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) Examiner: K. Nguyen

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) Art Unit: 2823

SUPPLEMENTAL RESPONSE TO OFFICE ACTION OF DECEMBER 23, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Supplemental to applicants' response filed March 23, 2004, please amend the captioned application as follows: